

Group Art Unit: 2886
Confirmation No.: 3799
Examiner: Nur, A.

Atty. Ref.: F04-018US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Tohru Koike et al.
Appl. No. : 10/575,714
Filed : May 8, 2006
For : METHOD FOR MEASURING A SURFACE PLASMON
RESONANCE AND NOBLE METAL COMPOUND USED FOR THE
SAME

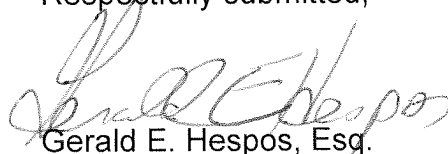
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

FOURTH INFORMATION DISCLOSURE STATEMENT

Sir:

Office Actions issued in connection with Japanese patent applications that are related to the above-identified US patent application. These Office Actions are not prior art, and hence are not listed on Form PTO/SB/08A. Neither of the Office Actions applies any prior art to the claims. Rather, both Office Actions relate to the appropriateness of the claims pending in divisional applications in Japan. The Examiner is invited to consider the comments of the respective Japanese Examiners.

Respectfully submitted,



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